



Attorney Docket No. 0756-7727

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Koichiro TANAKA et al.

Serial No.: 10/582,614

Filed: June 12, 2006

For: LASER IRRADIATION METHOD,
LASER IRRADIATION APPARATUS,
AND METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit:

) Examiner:

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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) Adrian Stamps

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

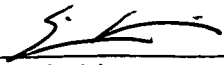
Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

A full English translation of JP 2003-228034 is submitted herewith. An English abstract of this reference was previously submitted with the Information Disclosure Statement of June 12, 2006.

This Information Disclosure Statement is being submitted before the issuance of a first Office Action on the merits, therefore, no fee is required.

Respectfully submitted,


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